

INFORMATION PROCESSING METHOD, COMPUTER PROGRAM, INFORMATION PROCESSING APPARATUS, AND SUBSTRATE PROCESSING SYSTEM

ABSTRACT

Provided is an information processing method, a computer program, an information processing apparatus, and a substrate processing system that can be expected to predict a state of a chamber internal component of a substrate processing apparatus. The information processing method according to the present embodiment includes: by an information processing apparatus, acquiring distribution information of irregularities on a surface of a chamber internal component of a substrate processing apparatus at a first time point, acquiring distribution information of irregularities of the chamber internal component at a second time point after substrate processing is performed from the first time point, and predicting distribution information of irregularities of the chamber internal component at a time point after the substrate processing is performed from the second time point, based on the acquired distribution information at the first time point and distribution information at the second time point.

Figure 1